



FIG. 2A

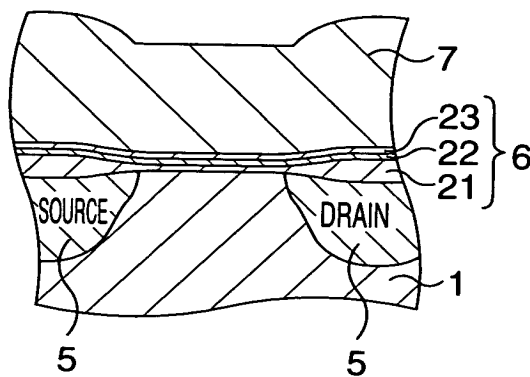


FIG. 2B

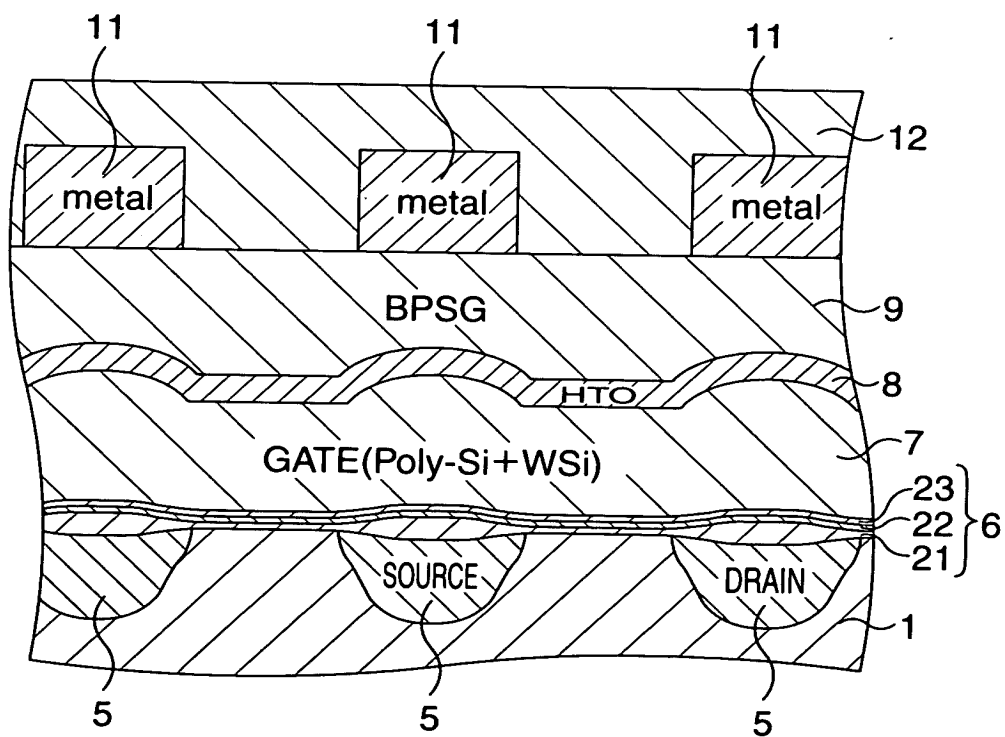


FIG. 3

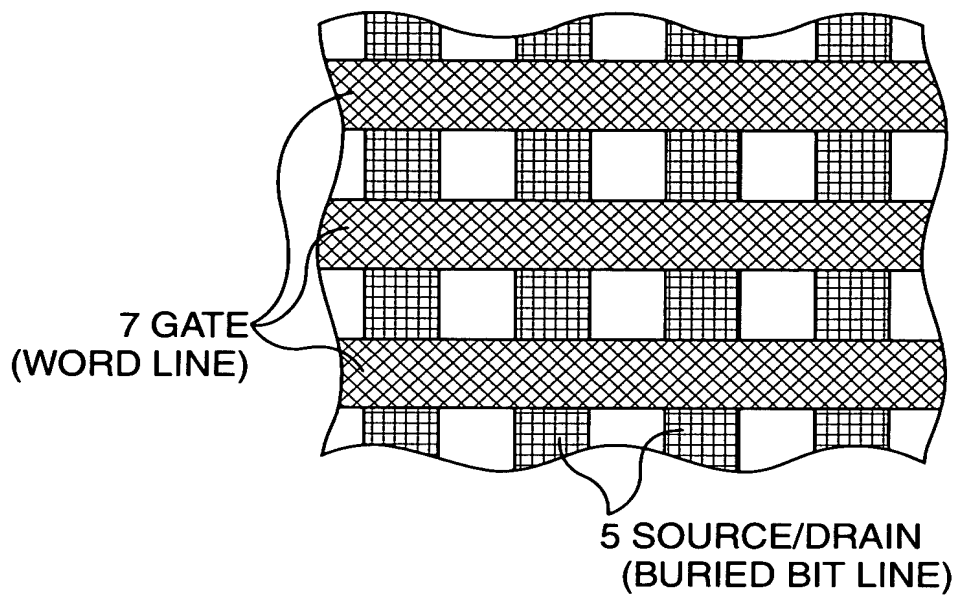


FIG. 4

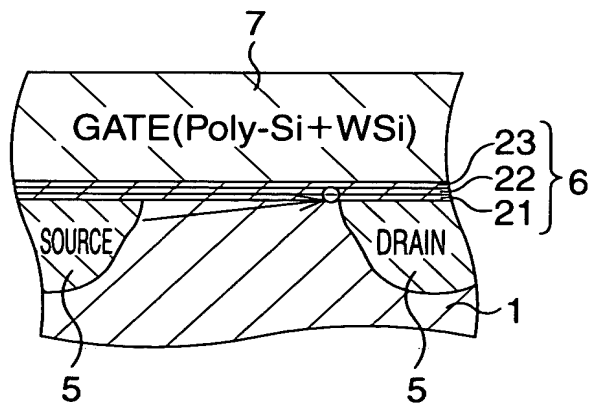


FIG. 5A

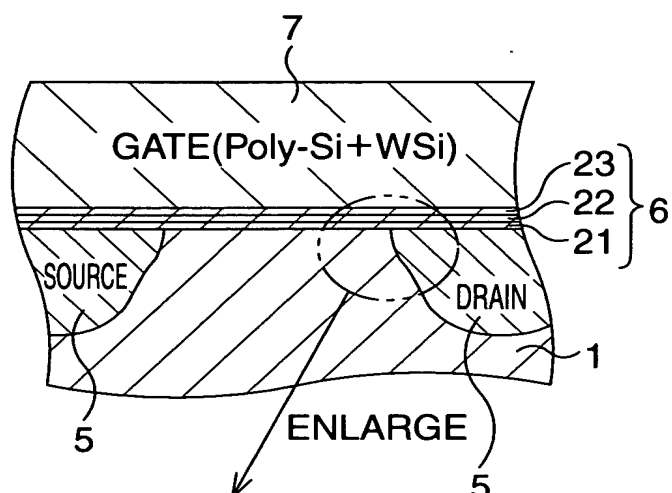


FIG. 5B

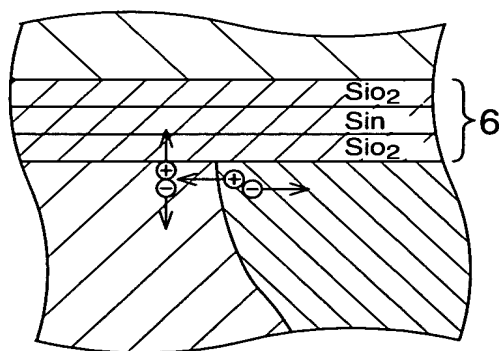


FIG. 6A

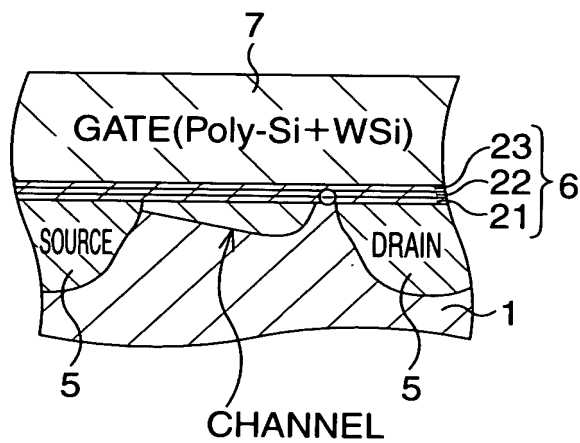


FIG. 6B

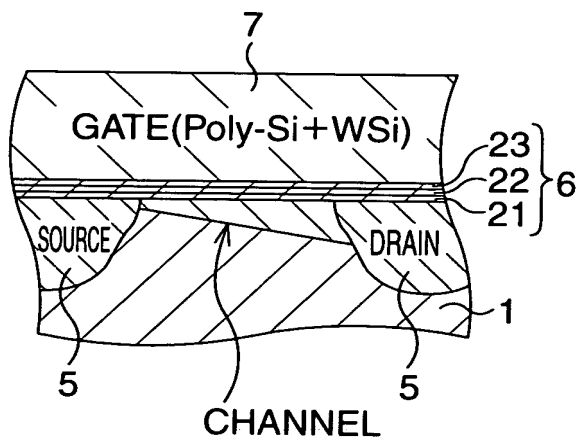


FIG. 7

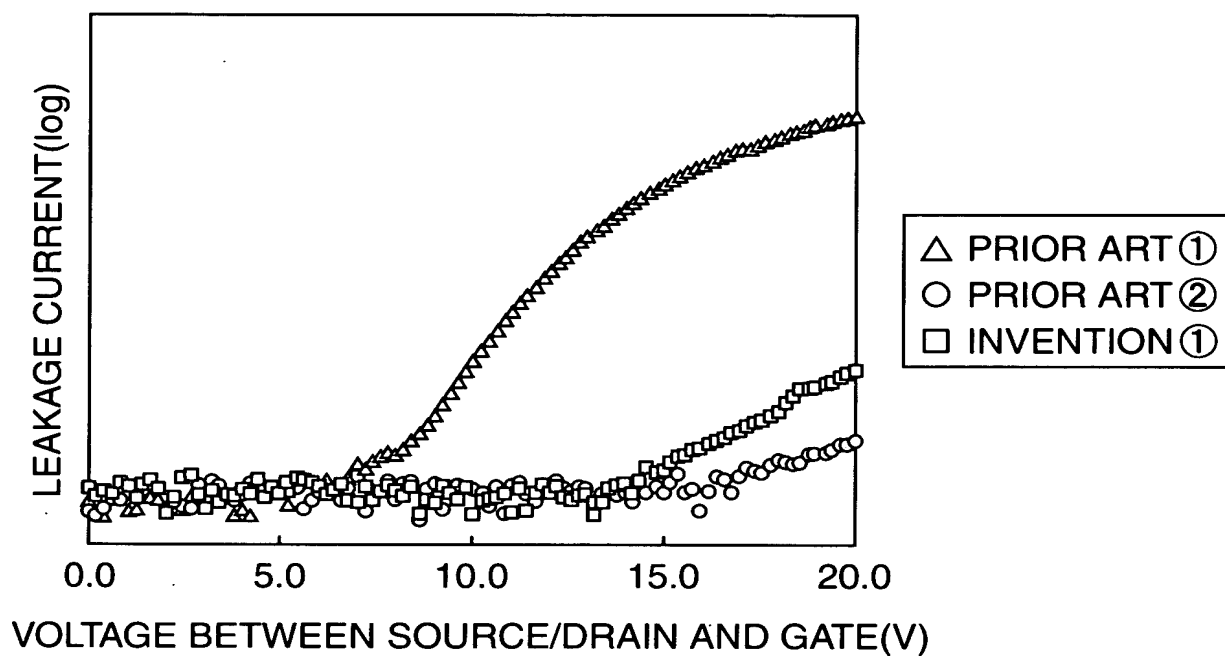


FIG. 8

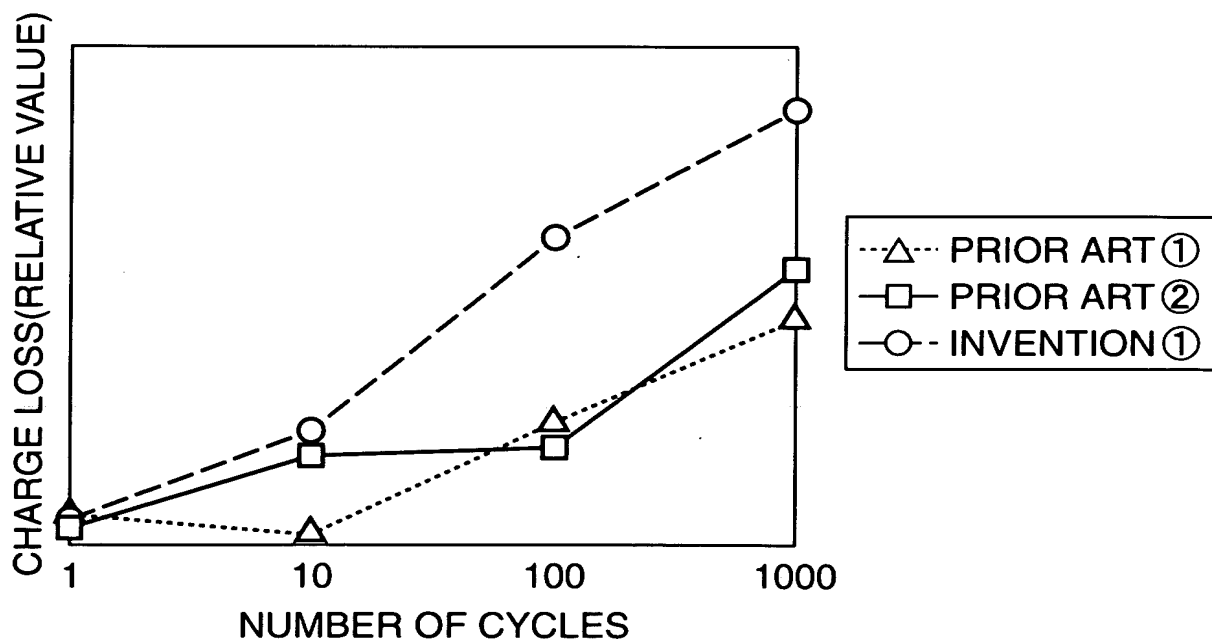


FIG. 9A

INVENTION①

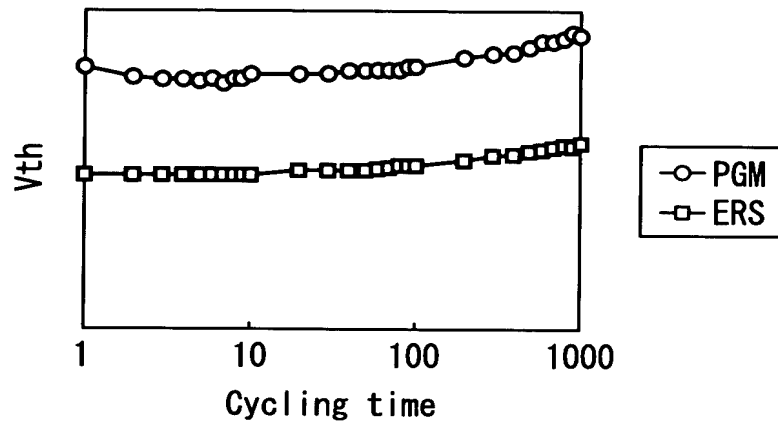


FIG. 9B

PRIOR ART①

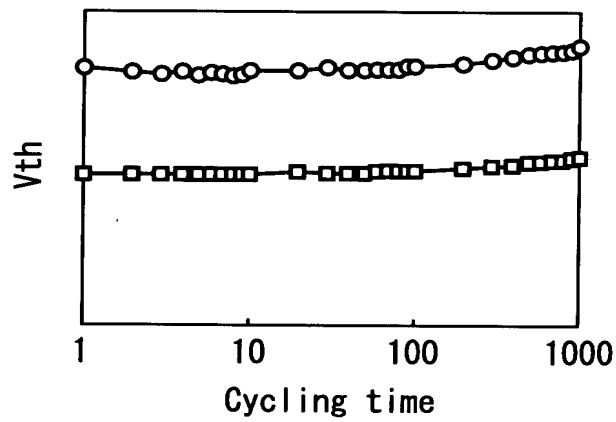


FIG. 9C

PRIOR ART②

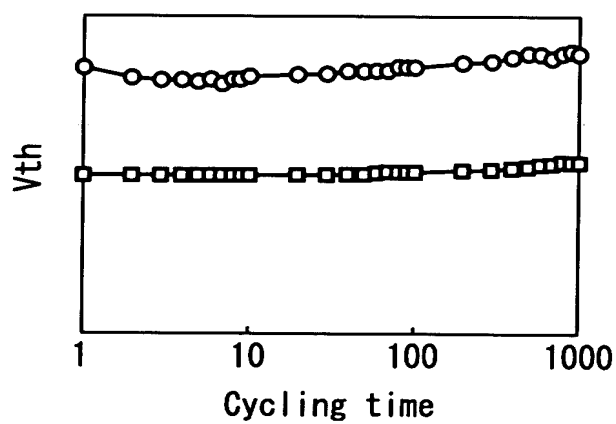


FIG. 10A

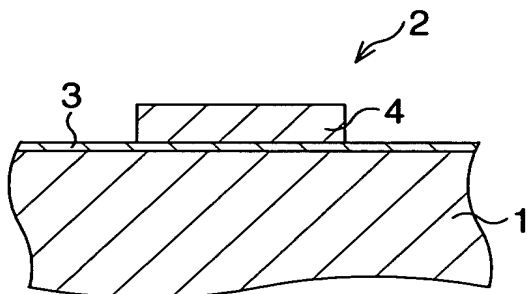


FIG. 10B

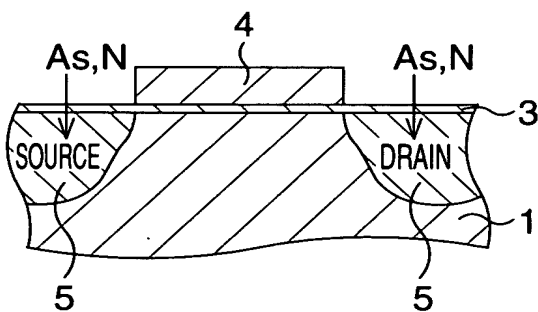


FIG. 10C

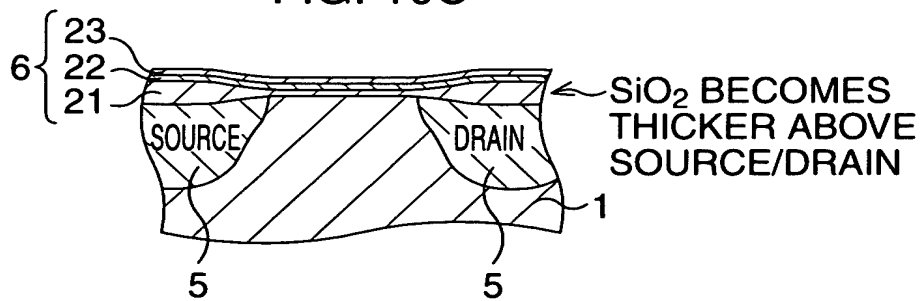




FIG. 11A

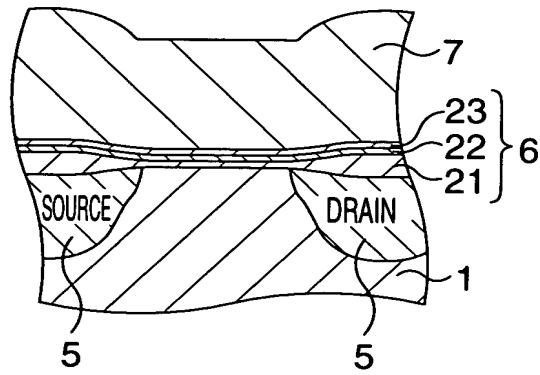


FIG. 11B

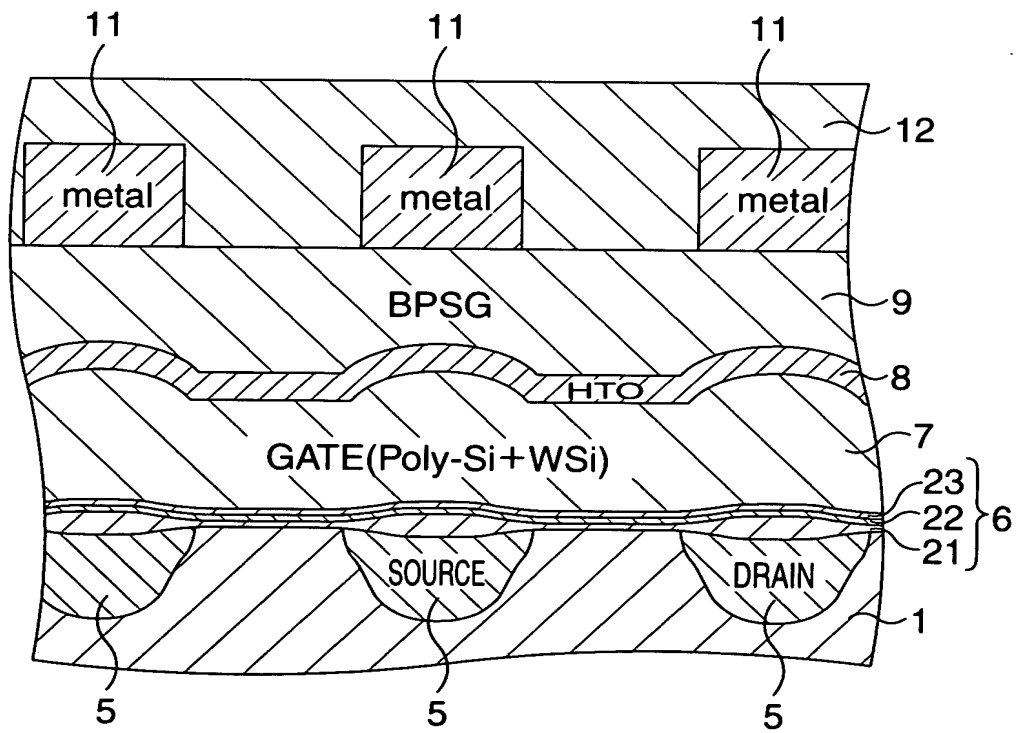


FIG. 12A

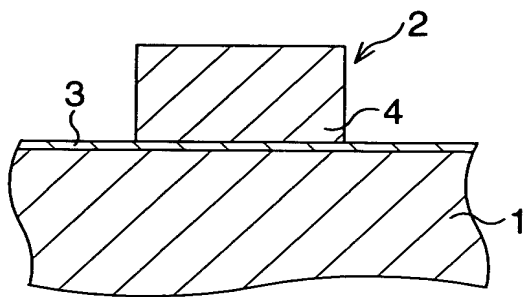
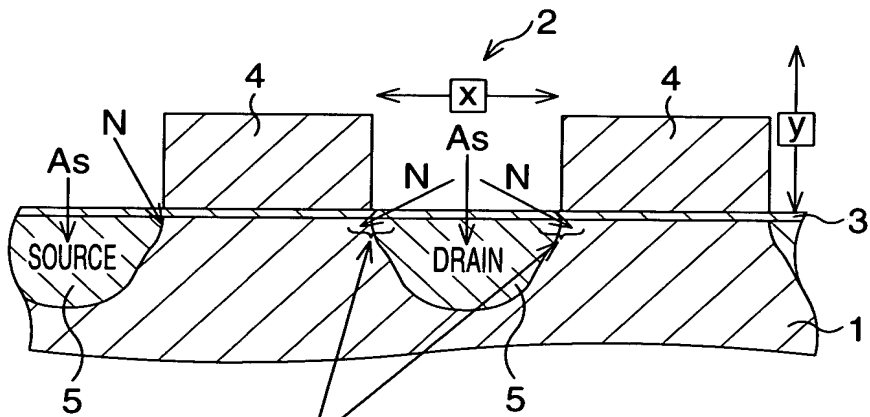
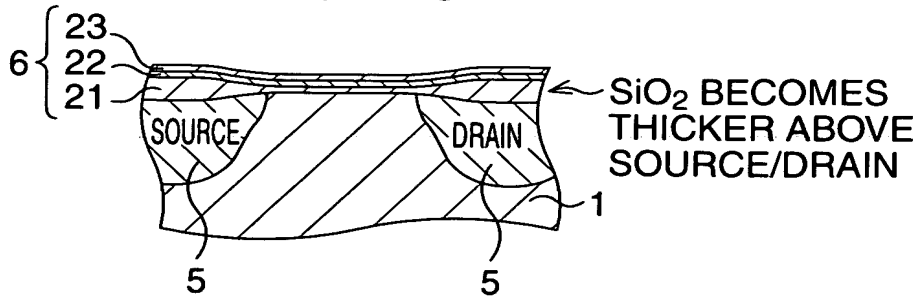


FIG. 12B



NITROGEN IS IMPLANTED INTO THIS REGION

FIG. 12C



SiO<sub>2</sub> BECOMES THICKER ABOVE SOURCE/DRAIN

FIG. 13A

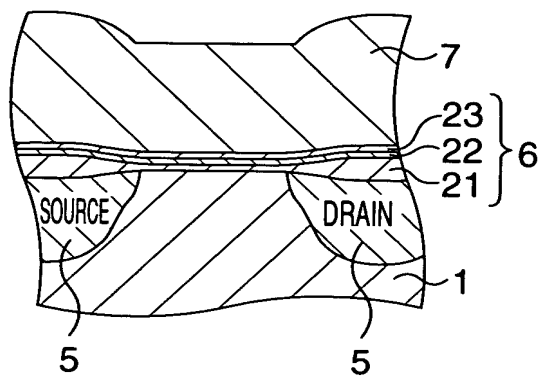


FIG. 13B

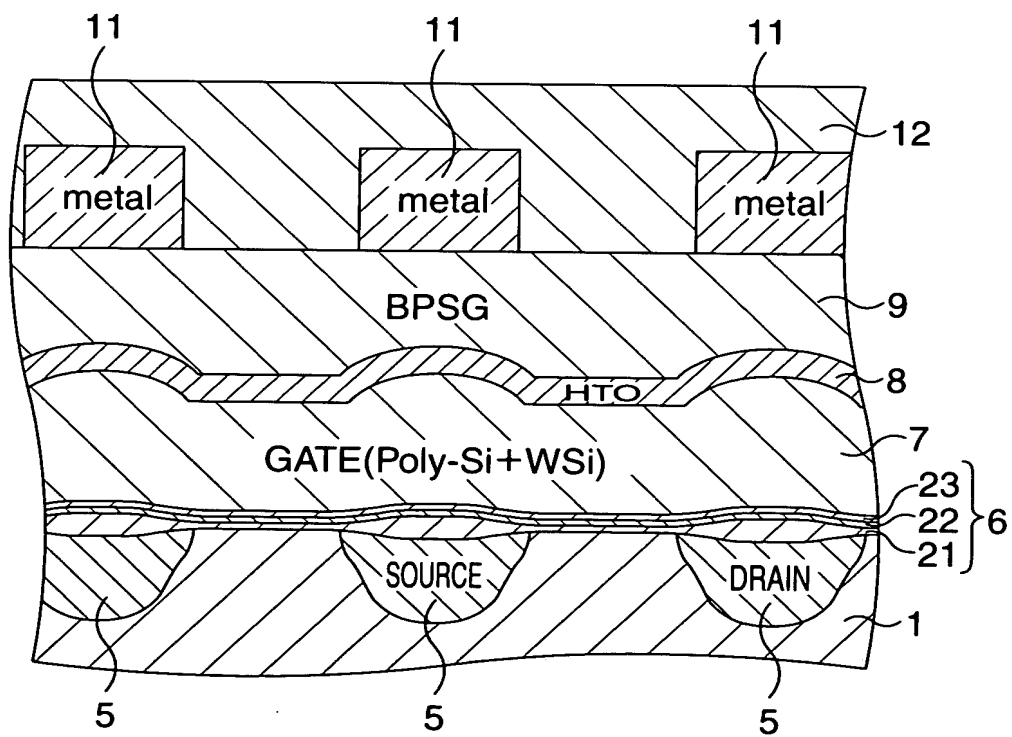


FIG. 14A

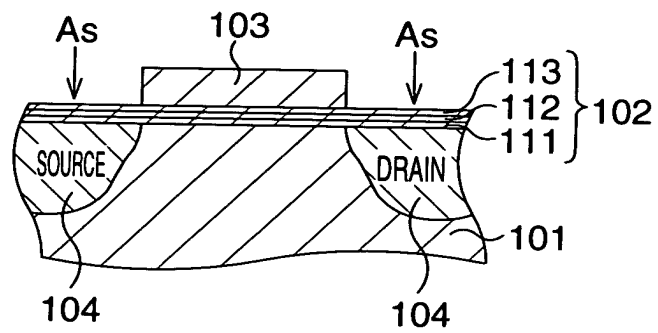


FIG. 14B

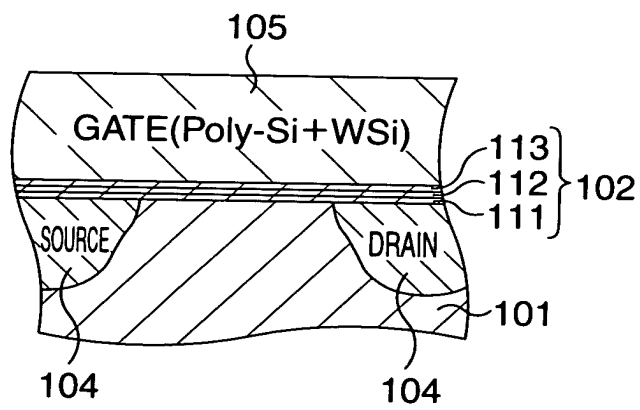


FIG. 15A

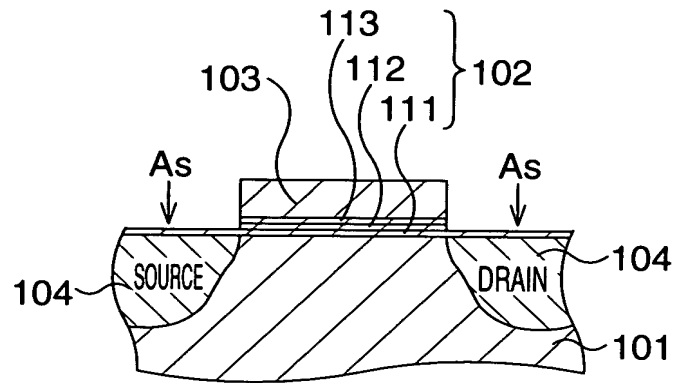


FIG. 15B

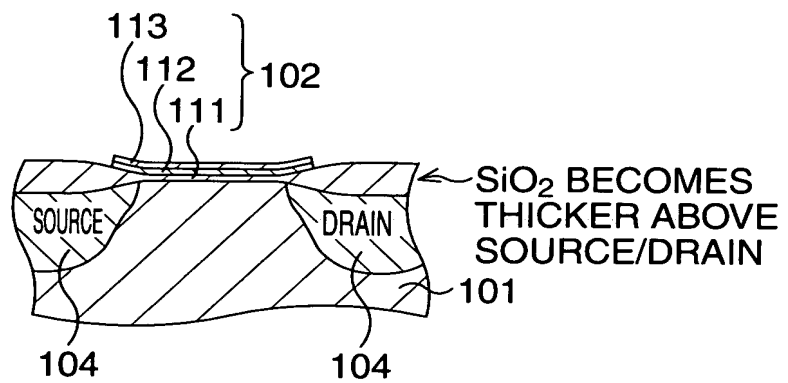


FIG. 15C

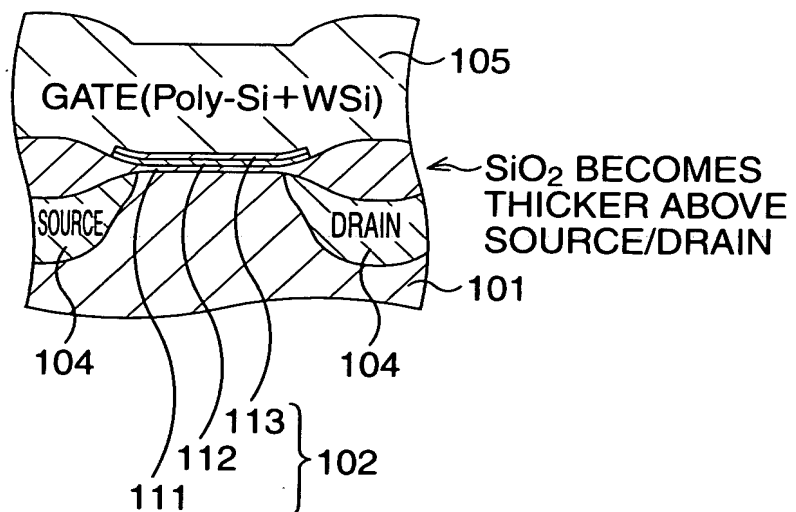


FIG. 16A

FIG. 16A

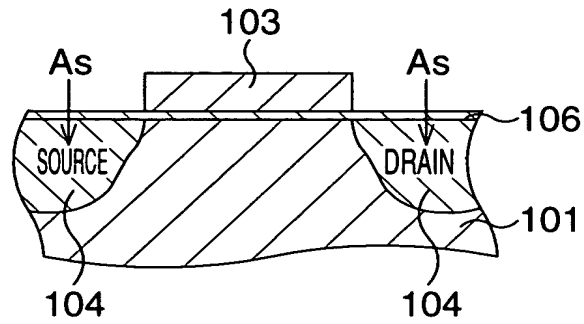


FIG. 16B

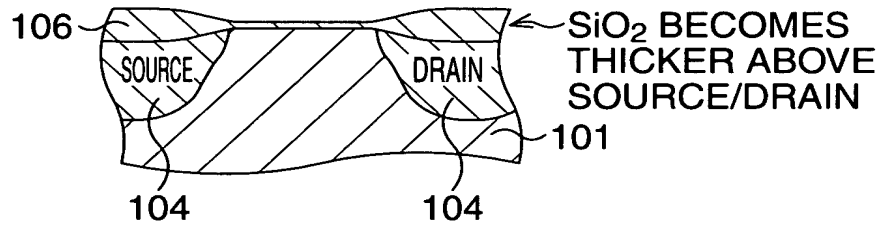


FIG. 16C

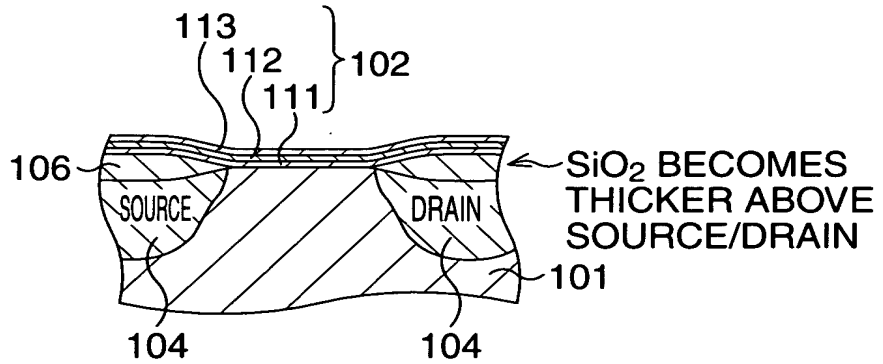


FIG. 16D

